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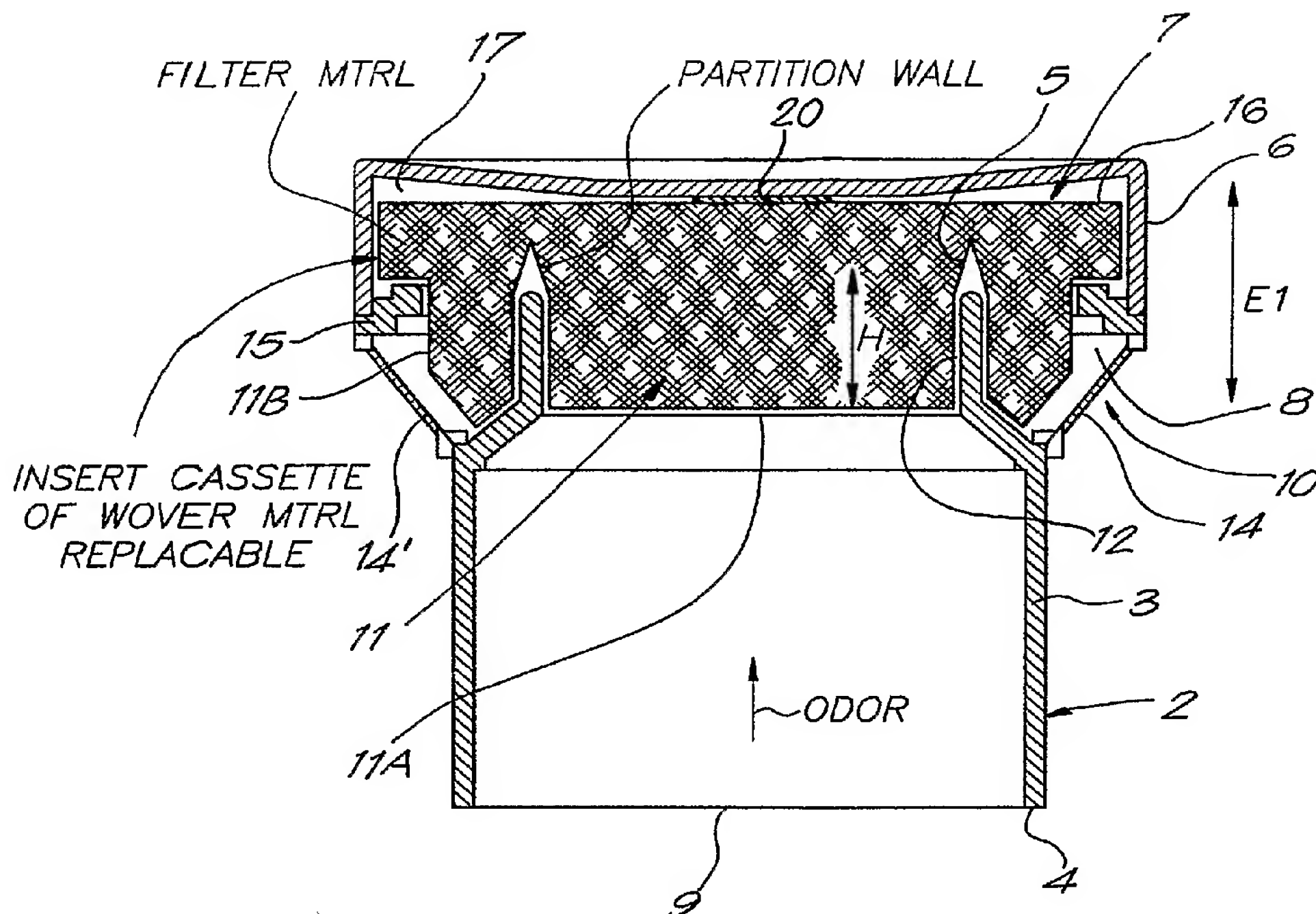
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(54) Title: AIR VENTING SYSTEM



(57) Abstract: Air venting system comprising: a body defining an inner chamber; and an odor absorbing means placed in the inner chamber, said odor absorbing means having an inlet surface and an exhaust surface, whereby the system is adapted for defining a gas flowing path between the inlet surface and the exhaust surface of the odor absorbing means, said flowing path in the odor absorbing means having at least two opposite flow path portions.

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